

IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

PATENT APPLICATION

Applicant: **Kawaguchi, et al.**

Case: **8033/ETCH**

Serial No.: **10/777,026**

Filed: **February 11, 2004**

Examiner: **Tran, Binh X.**

Group Art Unit: **1765**

Confirmation No.: **2197**

Title: **METHOD AND APPARATUS FOR REMOVING A HALOGEN-
CONTAINING RESIDUE**

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

S I R:

RESPONSE TO FINAL OFFICE ACTION DATED JULY 27, 2007

In response to the Final Office Action dated October 12, 2007 having a shortened statutory period for response set to expire on January 12, 2007, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although the Applicants believe that no fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 50-3562 for any fees, including extension of time fees, required to make this response timely and acceptable to the Office.